



Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	
				Filing Date	
				First Named Inventor	Mei-Ling Wu
				Group Art Unit	
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	284867-00040

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
En		KAZUHIKO ENDO ET AL., "Nitrogen doped fluorinated amorphous carbon thin films grown by plasma enhanced chemical vapor deposition for low dielectric constant interlayer dielectrics", <i>Appl. Phys. Lett.</i> , June 17, 1996, pp. 3656-3658, Vol. 68, No. 25.	
En		T.E. KARIS ET AL., "Ellipsometric measurement of solid fluorocarbon film thickness on magnetic recording media", <i>J. Appl. Phys.</i> , April 15, 1997, pp. 5378-5380, Vol. 81, No. 8.	
En		T.E. KARIS ET AL., "Characterization of a solid fluorocarbon film on magnetic recording media", <i>J. Vac. Sci. Technol.</i> , Jul/Aug 1997, pp. 2382-2387, Vol. 15, No. 4.	
En		T. E. KARIS ET AL., "Tribology of a Solid Fluorocarbon Film on Magnetic Recording Media", <i>IEEE Transactions on Magnetics</i> , July 1998, pp. 1747-1749, Vol. 34, No. 4.	
En		J. LUBGUBAN JR. ET AL., "Thermal stability and breakdown strength of carbon-doped SiO ₂ :F films prepared by plasma-enhanced chemical vapor deposition method", <i>Journal of Applied Physics</i> , April 15, 2000, pp. 3715-3722, Vol. 87, No. 8.	

Examiner Signature		Date Considered	2-20-03
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				Group Art Unit	
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	284867-00040

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
JW		4,693,799		Yanagihara et al.	09-15-1987	
		5,674,638		Grill et al.	10-07-1997	

FOREIGN PATENT DOCUMENTS								
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)				

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